

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/711,633	BAKIR ET AL.	
Examiner	Art Unit	
Sun J. Lin	2825	

SEARCHED					
Class	Subclass	Date	Examiner		
716	2	2/7/2006	JSL		
716	8	2/7/2006	JSL		
716	9	2/7/2006	JSL		
716	10	2/7/2006	JSL		
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INTERFERENCE SEARCHED				
Subclass	Date	Examiner		
2	2/7/2006	JSL		
8	2/7/2006	JSL		
9,10	2/7/2006	JSL		
	Subclass 2 8	Subclass Date 2 2/7/2006 8 2/7/2006		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
EAST [USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB]	2/7/2006	JSL		
IEEE	2/7/2006	JSL		
GOOGLE	2/7/2006	JSL		